



THERMAL SIMULATIONS of TOTEM MODULES

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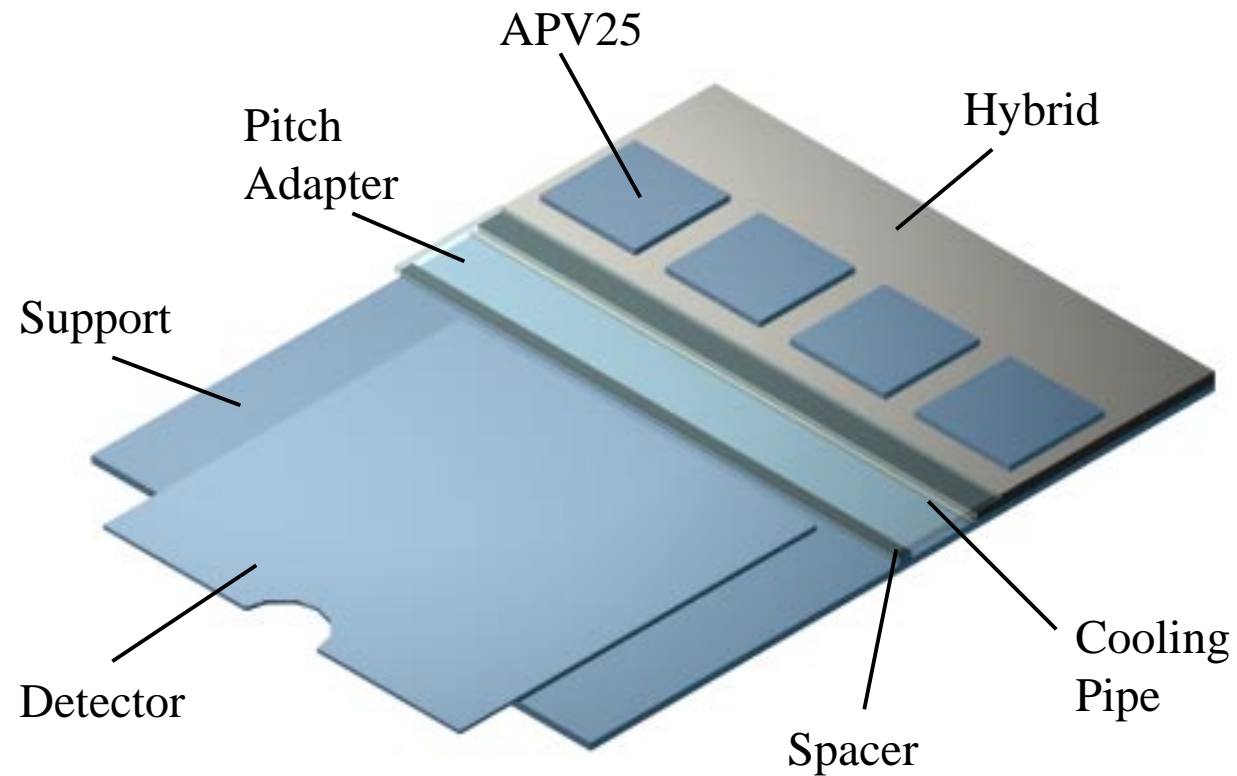
Seminar on Solid State Detectors - Geneva 11th July 2001

A G E N D A

- Prototype module
- Thermal Simulations
 - readout electronics and other thermal loads
 - modeling of the thermal behavior
 - mechanical design and choice of materials
 - results for different materials and cooling
- Thermal - Stress Simulations
- Conclusions - Next Steps



MECHANICAL DESIGN



SUMMARY OF HEAT LOADS

T H E R M A L L O A D S	
READOUT CHIPS	THERMAL RADIATION
Detector Surface: 30 x 30 mm	Aluminium Pot 300 K
Segmentation: $\approx 50 \mu\text{m}$	
Number of channels: 1280	Detector module 130 K
<i>APV-25 readout electronics</i>	Total thermal radiation load 235 mW
Power dissipation per channel: 2.31 mW	
Number of channels per chip: 128	
Number of chips per module: 10	
Power dissipation per module: 3.0 W	



THERMAL RADIATION LOAD

- **Two diffuse-gray surfaces forming a cylindrical or spherical enclosure:**

$$q_{1-2} = \frac{\sigma A_1 (T_1^4 - T_2^4)}{\frac{1}{\varepsilon_1} + \frac{A_1}{A_2} \left(\frac{1}{\varepsilon_2} - 1 \right)}$$

- **Assumptions:**
 - Silicon Module ($\varepsilon_1=0.19$ ▪ $A_1=38 \text{ cm}^2$) at 130 K
 - Aluminium Pot ($\varepsilon_2=0.06$ ▪ $A_2=345 \text{ cm}^2$) at 300 K

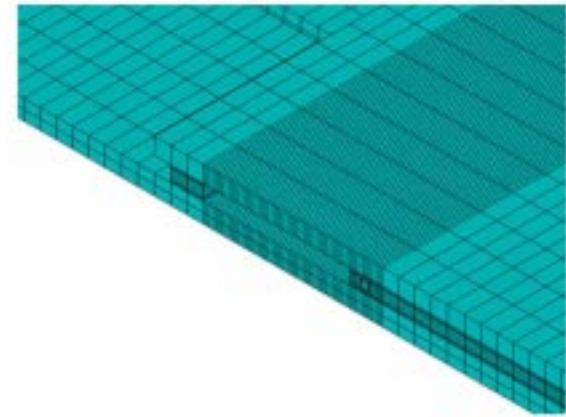
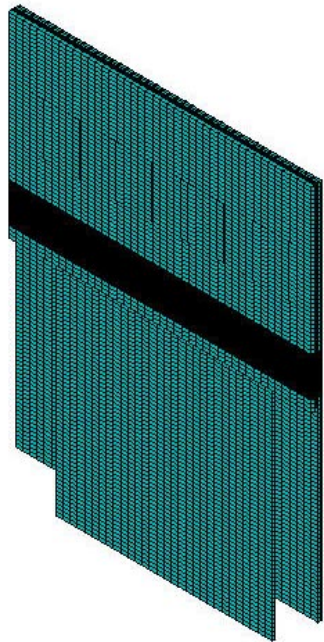


A N S Y S T H E R M A L M O D E L

M E S H I N G

Spatial accuracy = 0,5 mm

Number of Nodes \approx 51.000



B O U N D A R Y C O N D I T I O N S

Heat Loads

- Heat Flux

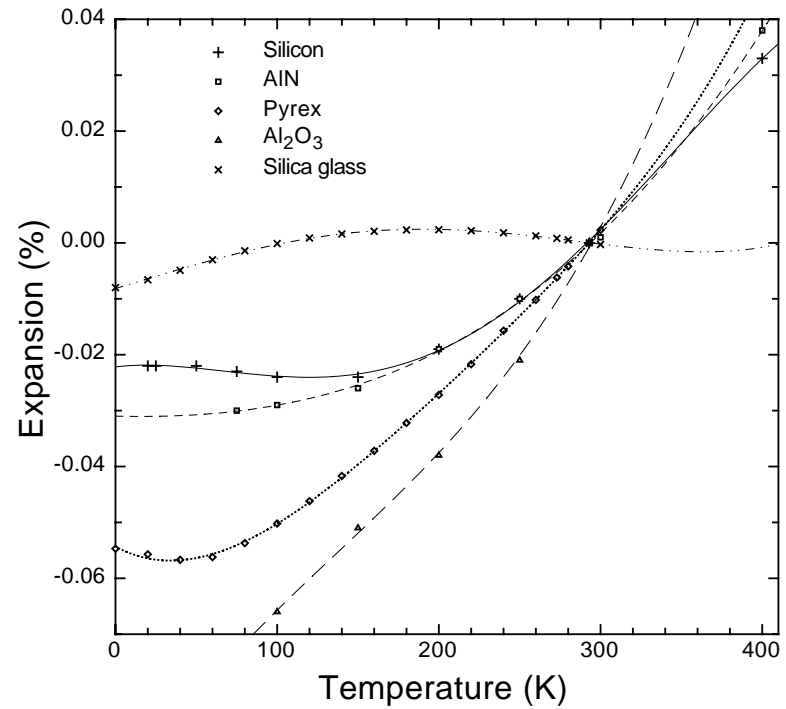
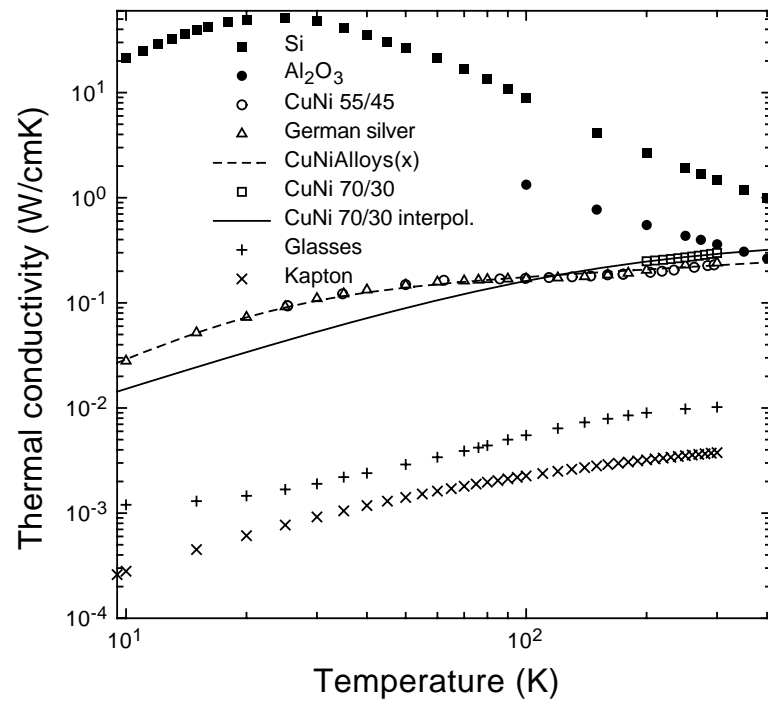
Heat Sink

- Bulk T fluid (110 K – 120 K)

Convection coefficient 10^4 W/m²K



THERMAL CONDUCTIVITY AND LINEAR EXPANSION



A N S Y S M O D E L

Materials of the reference module:

- strip detector ▪ silicon
- support ▪ silicon
- hybrid ▪ aluminum oxide
- pitch-adapter ▪ glass
- cooling pipe ▪ copper-nickel
- spacer ▪ silicon

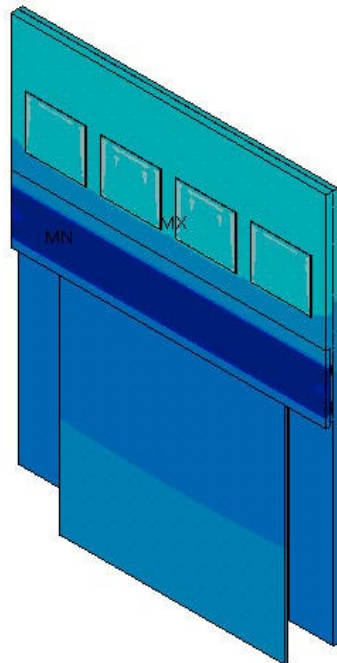
Components are glued together with radiation resistant cryogenic epoxy.

Thermal boundary conditions:

- APV25 power dissipation ▪ 1.2 W
- thermal radiation ▪ 235 mW
- fluid bulk temperature ▪ 120 K
- heat transfer coefficient ▪ 10^4 W/m²K



THERMAL SIMULATION ■ Pyrex PA ■ Al₂O₃ Hybrid ■ Silicon



ANSYS JUN 26 2001
16:32:05
NODAL SOLUTION
STEP=1
SUB =35
TIME=1
TEMP (AVG)
RSYS=0
PowerGraphics
EFACET=4
AVRES=Mat
SMN = 112.333
SMX = 115.804

■	112.333
■	112.719
■	113.105
■	113.49
■	113.876
■	114.261
■	114.647
■	115.032
■	115.418
■	115.804

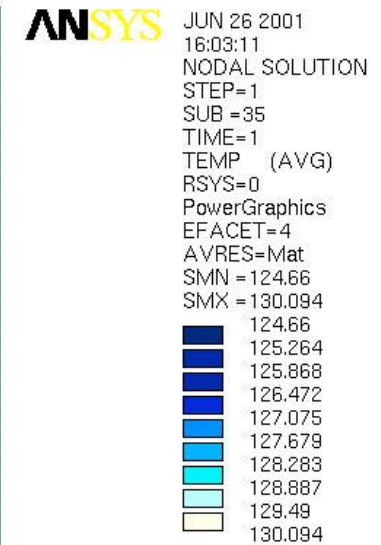
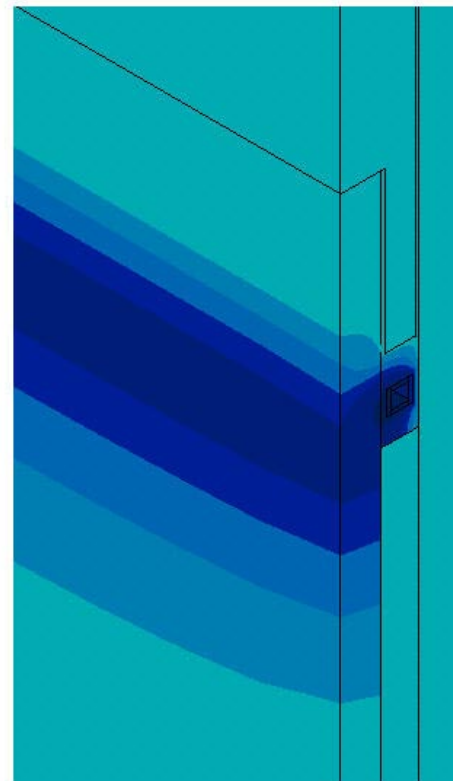
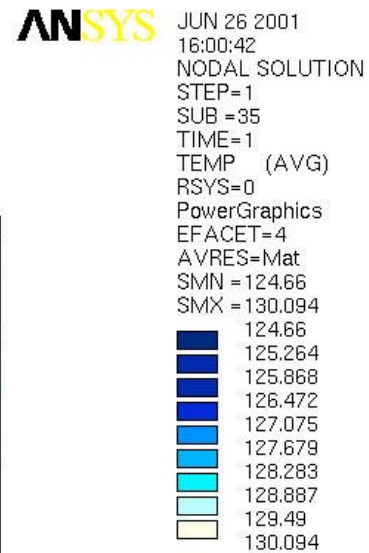
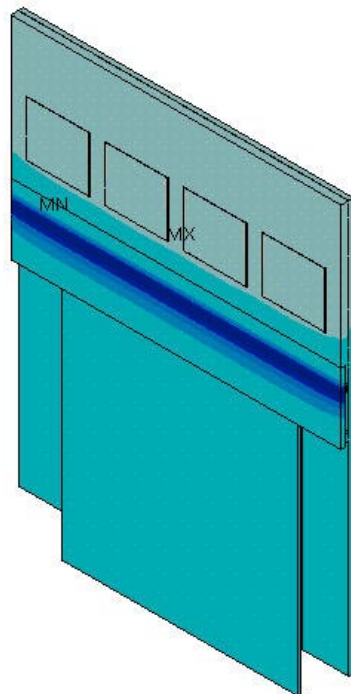


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SMX = 115.804

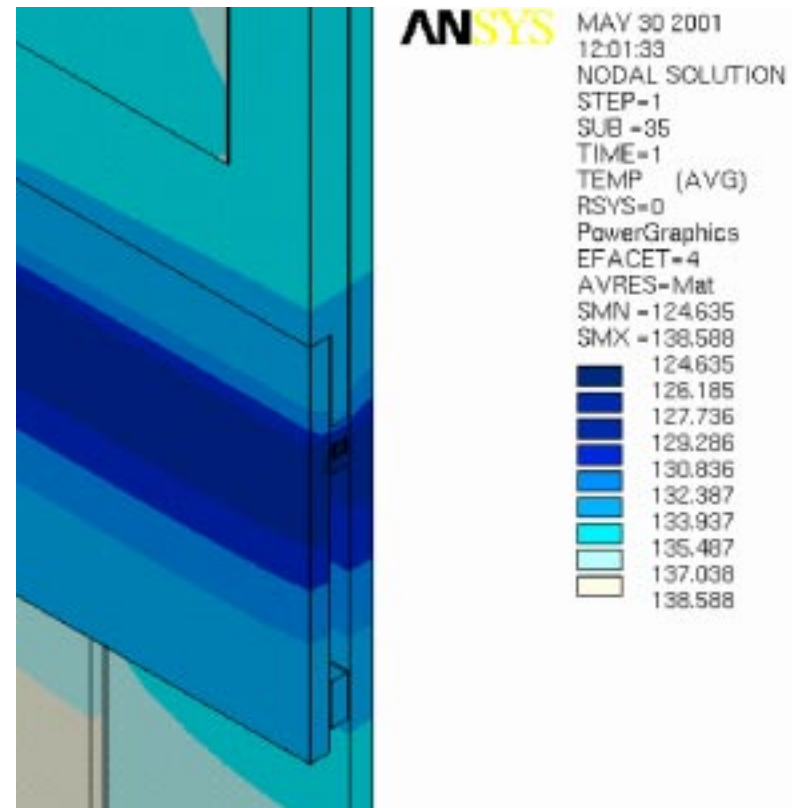
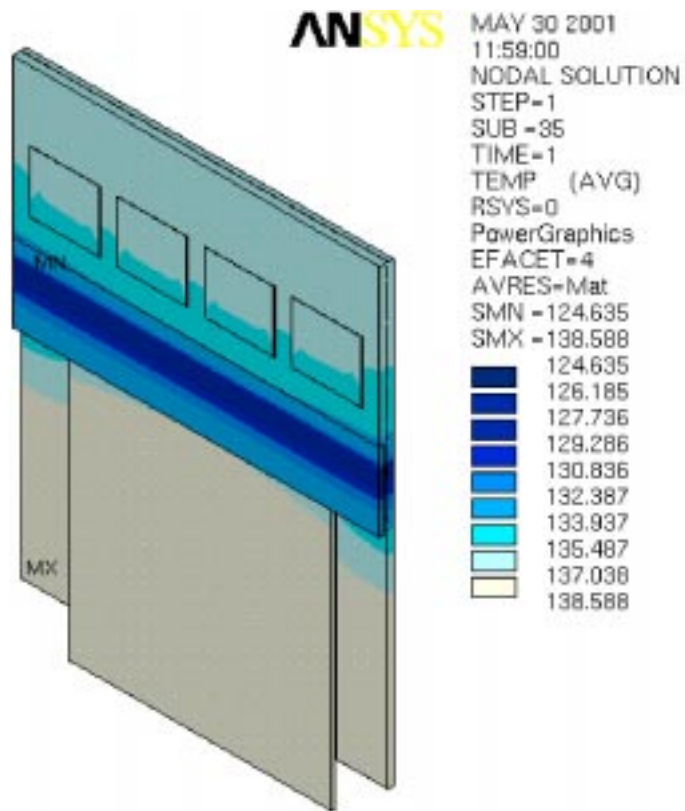
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■	112.719
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■	113.876
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■	114.647
■	115.032
■	115.418
■	115.804



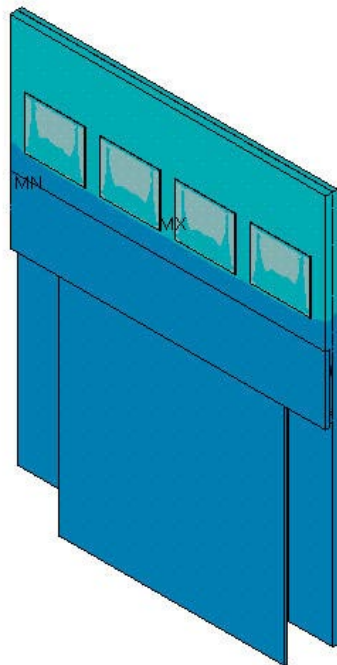
THERMAL SIMULATION ■ Pyrex PA ■ Al₂O₃ Hybrid ■ Silicon



THERMAL SIMULATION ■ Pyrex PA ■ AlN Support ■ Silicon

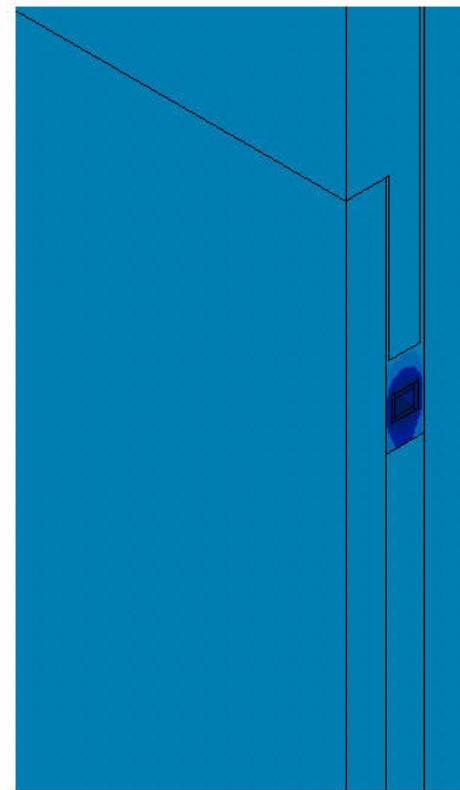


THERMAL SIMULATION ■ Silicon PA ■ Al₂O₃ Hybrid ■ Silicon



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AVRES=Mat
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SMX = 128.496

124.957
125.35
125.744
126.137
126.53
126.923
127.317
127.71
128.103
128.496



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TIME=1
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RSYS=0
PowerGraphics
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AVRES=Mat
SMN = 124.957
SMX = 128.496

124.957
125.35
125.744
126.137
126.53
126.923
127.317
127.71
128.103
128.496



T H E R M A L – S T R E S S S I M U L A T I O N

- Study the stresses that result from temperature gradient and different thermal dilatation coefficients of the materials
- Glue : high thermal dilatation coefficient, fillers
- Minimize displacements of the module with symmetric structures



C O N C L U S I O N - N E X T S T E P S

- Silicon, which is an excellent heat spreader at low temperatures, will be also used as constructive material.
- Evaporative cooling in microtubes provides ideal thermal separation of the heat source from the sensor and leads to a very homogeneous temperature profile in the module.
- Experiments are planned to validate the thermal and stress simulations (tooling and conductivity tests).
- Alignment of the detector relative to the pot
- Characterization of the APV-25 at low temperature

